

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi SHIRAI et al.

Group Art Unit: 2872

Application No.: 10/569,207

Examiner: A. AMARI

Filed: February 23, 2006

Docket No.: 127104

For: OPTICAL ELEMENT AND EXPOSURE APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
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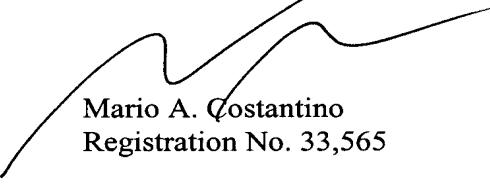
Sir:

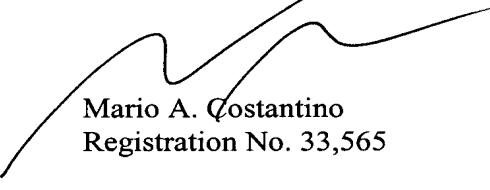
Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached.

- 1. One or more reference cited herein was cited in a foreign application. An English language version of the foreign search report is attached for the Examiner's information. See References 1-4.
- 2. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- 3. An English language Abstract of one or more non-English language reference is attached. See References 3-4.

- 4. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 3-4.
- 5. Reference 1 corresponds to reference 3.

Respectfully submitted,


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